



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant's Office

Paul A. Farrar

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

Docket No.: 1303.112US1

Serial No.: 10/681,481

Filed: October 8, 2003

Due Date: November 10, 2006

Examiner: Michail Kornakov

Group Art Unit: 1746

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

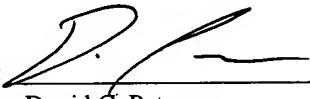
We are transmitting herewith the following attached items (as indicated with an "X"):

- Return postcard.
- Response to Restriction Requirement (9 pgs.).
- Communication Concerning Related Applications (1 pg.).

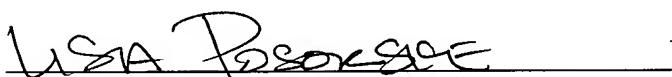
If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: 
Atty: David C. Peterson
Reg. No. 47,857

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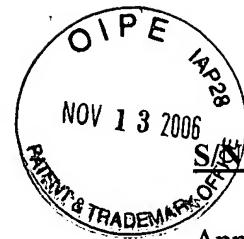
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Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



S/N 10/681,481

PATENT

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COMMUNICATION CONCERNING RELATED APPLICATION

MS Amendment

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Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
11458863	July 20, 2006	1303.112US2	METHOD OF CLEANING SEMICONDUCTOR SURFACES

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

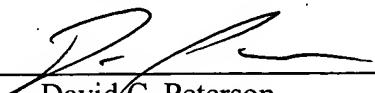
PAUL A. FARRAR

By Applicant's Representatives,

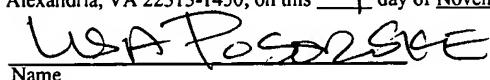
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Date 11-9-06

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David C. Peterson
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Name


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